

Notice of References Cited	Application/Control No. 10/586,180	Applicant(s)/Patent Under Reexamination DE VAAN, ADRIANUS J.S.M.	
	Examiner Rochelle Blackman	Art Unit 2862	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0007245 A1	01-2003	Edlinger et al.	359/487
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	M	US-			

FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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